

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Wang et al.

Group Art Unit: 2857

Serial No.:

09/954,449

Examiner: A. Gutierrez

Filed: 09/17/2001

For: RAPID THROUGHPUT SURFACE TOPOGRAPHICAL ANALYSIS

Attorney Docket No.: 1012-125(2001-023)

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

RESPONSE AND AMENDMENT

In response to the Office Action mailed July 15, 2004, please amend the above-identified application as follows and consider the following remarks.

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